

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :

Hong-Qiang Lu
Wei-Jen Hsia
Wilbur Catabay



Serial No. :

09/896,363

Group Art Unit :

2823

Filed :

June 28, 2001

Examiner :

Toledo, Fernando L.

For :

Dual Layer Barrier Film Techniques
To Prevent Resist Poisoning

Atty Docket :

LSI1P167 / 01-206

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, on the date below:

Connie Del Castillo

8/11/04 *Connie Del Castillo*
Date Signature

SUBMISSION OF FORMAL DRAWINGS PURSUANT TO 37 C.F.R. §1.85

Official Draftsman

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant hereby substitutes the enclosed formal drawings for those presently in the above referenced application.

LSI Logic Corporation
1621 Barber Lane, MS D-106
Milipitas, CA 95035
408-433-7475

Respectfully submitted,

Timothy Croll

Reg. No. 36,771

Date: 4 AUG 04